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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO	
09/938,056	08/23/2001	Youlin J. Li	. 7103/205	1652	
757	7590 08/01/2005		EXAMINER		
BRINKS HOFER GILSON & LIONE			NGUYEN, GEORGE BINH MINH		
P.O. BOX 10395			ART UNIT	PAPER NUMBER	
CHICAGO,	IL 60610		AKI UNII	FAFER NUMBER	
			3723		

DATE MAILED: 08/01/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

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		Application No.	Applicant(s)				
		09/938,056	LI ET AL.				
	Office Action Summary	Examiner	Art Unit				
		George Nguyen	3723				
Period fo	The MAILING DATE of this communication app or Reply	ears on the cover sheet with the d	orrespondence add	ress			
THE - Exte efter - If the - If NO - Failu Any	ORTENED STATUTORY PERIOD FOR REPL' MAILING DATE OF THIS COMMUNICATION. nsions of time may be available under the provisions of 37 CFR 1.1. SIX (6) MONTHS from the mailing date of this communication. period for reply specified above is less than thirty (30) days, a reply period for reply is specified above, the maximum statutory period vere to reply within the set or extended period for reply will, by statute reply received by the Office later than three months after the mailing ed patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be ting within the statutory minimum of thirty (30) day will apply and will expire SIX (6) MONTHS from a cause the application to become ABANDONE	mely filed ys will be considered timely. In the mailing date of this com ED (35 U.S.C. § 133).	nmunication.			
Status		,					
1)⊠	Responsive to communication(s) filed on 29 M	ay 2005.					
2a)⊠	This action is FINAL . 2b) ☐ This	action is non-final.					
3)□	Since this application is in condition for allowar	nce except for formal matters, pro	osecution as to the r	merits is			
	closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.						
Disposit	ion of Claims						
4)⊠	Claim(s) 15-25 is/are pending in the application	n.					
	4a) Of the above claim(s) is/are withdraw	wn from consideration.					
· —	Claim(s) is/are allowed.						
	Claim(s) <u>15-25</u> is/are rejected.						
7)∐							
·	Claim(s) are subject to restriction and/o	r election requirement.					
Applicat	ion Papers						
·	9) The specification is objected to by the Examiner.						
10)	10)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.						
	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
44)[7]	Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d). The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.						
11)[]	The oath or declaration is objected to by the Ex	aminer. Note the attached Office	; Action of form PTC	J-152.			
Priority (ınder 35 U.S.C. § 119						
-	Acknowledgment is made of a claim for foreign ☐ All b)☐ Some * c)☐ None of:)-(d) or (f).				
	1. Certified copies of the priority document		taa Na				
	2. Certified copies of the priority document	• •		Stage			
	3. Copies of the certified copies of the prior application from the International Bureau	- -	eu III tilis ivational S	olaye			
* 5	See the attached detailed Office action for a list		ed.				
Attachmen	t(s)						
	e of References Cited (PTO-892)	4) Interview Summary	/ (PTO-413)				
2) 🔲 Notic	e of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail D	ate	150)			
	mation Disclosure Statement(s) (PTO-1449 or PTO/SB/08) r No(s)/Mail Date	5) Notice of Informal F 6) Other:	atent Application (FTO-	104)			
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DETAILED ACTION

Receipt is acknowledged of Applicant's amendment filed on May 27, 2005.

Claims 15-25 are presented for examination. Claims 1-14 were canceled.

Response to Amendment

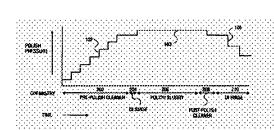
- 1. The affidavit filed on May 27, 2005 under 37 CFR 1.131 has been considered but is ineffective to overcome the Miller et al. 6,719,614 reference.
- 2. The evidence submitted is insufficient to establish a conception of the invention prior to the effective date of the Miller et al.'6,719,614 reference. While conception is the mental part of the inventive act, it must be capable of proof, such as by demonstrative evidence or by a complete disclosure to another. Conception is more than a vague idea of how to solve a problem. The requisite means themselves and their interaction must also be comprehended. See *Mergenthaler v. Scudder*, 1897 C.D. 724, 81 O.G. 1417 (D.C. Cir. 1897). Since the claims are directed to an apparatus, there is no disclosure from the affidavit to support the specific limitations of "a delivery system... maintained separately" set forth in claims 15, 17, and 21.
- 3. The evidence submitted is insufficient to establish a reduction to practice of the invention in this country or a NAFTA or WTO member country prior to the effective date of the Miller et al.'6,719,614 reference. In the affidavit, page 3, it is insufficient to establish a reduction to practice of the invention by merely say "yes" to section 5. The affidavit failed to provide the specific date of conception and the specific date of reduction to practice.

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Claim Rejections - 35 USC § 103

- 4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 5. Claims 15-25 are rejected under 35 U.S.C. 103(a) as being unpatentable over Miller et al.'6,719,614 in view of Perlov et al.'6,086,457.

With reference to Figure 2, col. 5, lines 40-57, Miller'6,719,614 discloses a method of polishing a copper layer comprising: a) cleaning an oxidized substrate surface with a pre-polish cleaning solution substantially free of abrasives and oxidizers and b) subsequently to the cleaning operation, polish said substrate surface with oxidizing slurry.



An embediment of the method of polishing a copper layer on a wafer, in accordance with the present invention, is described in conjunction with FIG. 3. More particularly, in this illustrative embadiment, the copper layer is subjected to a pre-polish cleaning operation. This cleaning operation is 40 typically performed at room temperature, but is not required to be at room temperature. As shown in FIG. 3, oxidation is cleaned from the surface of a copper layer prior to polishing (302). This oxidation eleaning operation removes exidized portions of the copper surface so as to facilitate the initiation 45 of chemical mechanical polishing. The eleaning solution includes a chelating organic acid buffer system and does not include the abrasives or oxidizers that are typically added to copper polish slarries. In this regard, the pre-polish cleaning solution is substantially free of alresives and oxidizers, so Subsequent to the cleaning operation, the copper layer is subjected to a CMP operation (304).

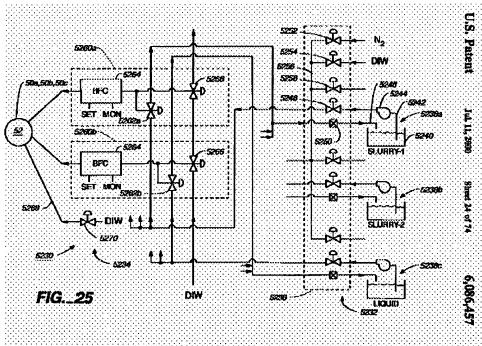
In col. 4, lines 47-67, Miller discloses that the method can be implemented with more polishing platens, and slurries may be delivered to the polishing apparatus with more then one dispensers.

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45 used for a period 202 that corresponds to a first portion of ramp-up phase 102, a DI water rince is used for a period 204 corresponding to a second portion of ramp-up phase 102, a polishing sturry is used for a period 206 that corresponds to main polishing phase 103, a post-polish chemistry, i.e., a 50 chemical formulation different from that of the polishing slikely, is used for a period 208 that corresponds to a first portion of tamp-down phase 105, followed by a ruse with: de-innized water for a period 210 that corresponds to a second portion of ramp-down phase 105. This embodiment: 55 of the present invention may be alternatively implemented. with one or more polishing plateas. The various cleaners, rinses, and sharies may be delivered to the polishing equipment by way of one or more dispensers. The various ingredients may be pre-mixed and delivered to the polishing 60 pad by panaping through a dispenser. Alternatively, various single ingredients, or combinations of ingredients, may be pumped through a plurality of dispensers and thereby delivcred to the polishing pad.

In the embodiment of P16, 2, polishing pressure rump-up as phase 162 represents a range of zero to five pounds per square inch (psi). In typical embodiments the high end of the pressure ramp is in the range of 1 to 5 psi.

However, Miller does not specifically discloses that the sources are maintained separately, and a transfer mechanism to move wafer to and from the first polishing station and the second polishing station.



With reference to

Figs. 19-25, col. 32, line 18, to col. 34, line 26, Perlov discloses the claimed invention

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including: a) a first CMP polisher 50a; b) second CMP polisher 50b; b) a plurality of slurry suppliers 5236a-c which are interchangeably supplied to polishers 50a-c. The advantage of the invention is to be able to simultaneously processing a plurality of wafers in order to improve the output.

Thus, it would have been obvious to one having ordinary skill in the art at the time the invention was made to have modified the method and apparatus of Miller with a multiple polishing stations and multiple slurry dispensers as taught by Perlov et al.'6,086,457 in order to achieve an optimal throughput (col. 6, lines 1-3).

Response to Arguments

6. Applicant should submit an argument under the heading "Remarks" pointing out disagreements with the examiner's contentions. Applicant must also discuss the references applied against the claims, explaining how the claims avoid the references or distinguish from them.

Conclusion

7. **THIS ACTION IS MADE FINAL.** Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of

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the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to George Nguyen whose telephone number is 571-272-4491. The examiner can normally be reached on Monday-Friday/630AM-300PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Joseph Hail can be reached on 571-272-4485. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

George Nguyen Primary Examiner

GN – July 28, 2005

Primary Examiner

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